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PATENT #

4-1702
Mullish

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Halimaoui, et al.

Serial No.: 09/744,877

Filed: January 29, 2001

For: PROCESS FOR FORMING AN
OXIDE LAYER OF NON-UNIFORM
THICKNESS ON THE SURFACE OF
A SILICON SUBSTRATE

§ Examiner: Unknown
§ Group Art Unit: 2812
§ Attorney Docket: 5310-03000/EBM

CERTIFICATE OF MAILING
37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Office of Initial Patent Examination, Customer Service Center, Washington, D.C. 20231, on the date below:

11-10-01

Jackie L. Pitre

REQUEST FOR CORRECTED FILING RECEIPT

Commissioner for Patents
Office of Initial Patent Examination
Customer Service Center
Washington, D.C. 20231

Sir:

A corrected filing receipt is hereby requested in view of the errors which appear in the original. The title information is stated as "Method for forming an oxide layer with non-uniform thickness of a silicon substrate" and should be corrected to read "**Process For Forming An Oxide Layer Of Non-Uniform Thickness On The Surface Of A Silicon Substrate**". For the convenience of the Patent and Trademark Office, attached is a photocopy of the original receipt on which the errors have been noted in red.

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No fee is believed to be due in connection with the filing of this document, however should any fee be deemed necessary, the Commissioner is hereby authorized to deduct said fee from Conley, Rose & Tayon Deposit Account No. 50-1505/5310-03000/EBM.

Respectfully submitted,



Mark R. DeLuca
Reg. No. 44,649

CONLEY, ROSE & TAYON, P.C.
P.O. BOX 398
AUSTIN, TX 78767-0398
(512) 703-1423 (voice)
(512) 703-1250 (facsimile)

Date: 11/7/01